

**Notice of References Cited**

Application/Control No. 09/900,364	Applicant(s)/Patent Under Reexamination VAN POELJE ET AL.	
Examiner Shaojia A. Jiang	Art Unit 1617	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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**NON-PATENT DOCUMENTS**

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